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## AMENDMENT TRANSMITTAL LETTER

Docket No.  
291958237US

Application No. 10/729,349-Conf. #8267	Filing Date December 5, 2003	Examiner H. D. Wilkins	Art Unit 1742
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Applicant(s): Klocke et al.

Invention: CHAMBERS, SYSTEMS, AND METHODS FOR ELECTROCHEMICALLY PROCESSING MICROFEATURE WORKPIECES

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

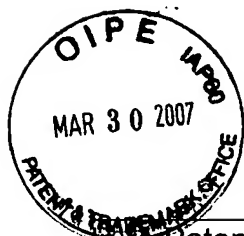
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	33	- 48 =		x	
Independent Claims	6	- 11 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within second month; Two Statutory Disclaimers					450.00 260.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					710.00

☒ Large Entity☐ Small Entity☐ No additional fee is required for this amendment.☐ Please charge Deposit Account No. 50-0665 in the amount of \$ \_\_\_\_\_  
A duplicate copy of this sheet is enclosed.☒ The amount of \$ 710.00 to cover the fees are being paid via EFT Account.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0665  
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

John M. Weckin  
Attorney/Agent Reg. No.: 42,216

Dated: March 30, 2007

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Docket No.: 291958237US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inter Patent Application of:  
Klocke et al.

Application No.: 10/729,349

Confirmation No.: 8267

Filed: December 5, 2003

Art Unit: 1742

For: CHAMBERS, SYSTEMS, AND METHODS  
FOR ELECTROCHEMICALLY  
PROCESSING MICROFEATURE  
WORKPIECES

Examiner: H. D. Wilkins

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated 31 October 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.